

## U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

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APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/707710		377 385	92	288 288A	Wang <i>Sangham</i>

APPLICANTS  
Jeffrey Korn  
Peter Whitney  
Dale FlandersTITLE  
System and process for fast alignment polarization extinction ratio compensation in semiconductor laser systemPTO-2040  
12/99Information contained  
herein is hereby  
disclaimed.

(Legal Instruments Examiner)

(Date)

RECORDED BY

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(Attached in pocket on right side)PTO-489A  
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(FACE)